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In re Application of Hiroshi Ikeda et al.

OFFICE OF PETITIONS

Application No. 09/463,961

**DECISION ON PETITION** 

Filed: May 25, 2000

Attorney Docket Number: 0160-0193-0-Title: PROCESS AND APPARATUS FOR

TREATING SEMICONDUCTOR PRODUCTION EXHAUST GASES.

This is a decision on the petition under 37 C.F.R. §1.182, filed September 7, 2005, requesting that the above-identified application be accorded a filing date of March 9, 2000<sup>1</sup>.

It is noted that the signature block above the name of the Petitioner is blank.

37 C.F.R. §10.18(a) sets forth:

For all documents filed in the Office in patent, trademark, and other non-patent matters, except for correspondence that is required to be signed by the applicant or party, each piece of correspondence filed by a practitioner in the Patent and Trademark Office must bear a signature, personally signed by such practitioner, in compliance with § 1.4(d)(1) of this chapter.

Since this petition has been submitted without a signature, the petition cannot be processed. For this reason, the petition under 37 CFR §1.182 is **DISMISSED**.

Telephone inquiries regarding this decision should be directed to the undersigned at (571) 272-3225. All other inquiries concerning examination procedures or status of the application should be directed to the Technology Center.

Paul Shanoski Senior Attorney Office of Petitions

United States Patent and Trademark Office

<sup>1</sup> It is noted that with this facsimile transmission, Petitioner has also submitted a petition requesting a change to the title of this application. As that is not handled by this part of the Office, the appropriate section of the Office will be notified of this request in due course.